

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Ricky Amos

Group Art Unit: 2815

Serial No.: 09/995,031

Examiner: Matthew Landau

Filed: Nov. 29, 2001

In Response to Office Action  
Dated: Jan. 22, 2003

For: High Temperature Processing Compatible Metal Gate  
Electrode For FETs and Method for Fabrication

Attorney Docket No.: YOR920010633US1 (062)

Certificate of Facsimile

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Patent Office via facsimile no: (703) 872-9319 on March 24, 2003

Kathy Dixon

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REQUEST FOR RECONSIDERATION

Assistant Commissioner  
for Patents  
Washington, D.C. 20231

Dear Sir:

In response to a final Office Action mailed January 22, 2003, please enter the following amendments and consider the following remarks.

**TUNG &**  
**ASSOCIATES**  
Intellectual Property Law

Date: March 24, 2003

TO: Examiner Matthew Landau (703) 872-9319  
Art Unit: 2815

**FAX RECEIVED**

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MAR 24 2003

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Subject Matter: 09/ 995,031 Attorney Doc: YOR920010633US1 (062)

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